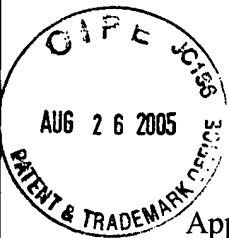


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ryosuke Usui et al.

Art Unit : 2823

Serial No. : 10/724,954

Examiner : William M. Brewster

Filed : December 1, 2003

Title : CIRCUIT DEVICE MANUFACTURING METHOD

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MAY 25, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 23, 2005

Date of Deposit

Roselynn Scarfo

Signature

ROSELYNN SCARFO

Typed or Printed Name of Person Signing Certificate